

DISCLO	MATION OSURE ON FORM FOR T APPLICATION		: No.: 3536 C01 ant(s): JAMES C.		al No.: 09/7	775,173	RECE MAY 2 1 26 C 12	IVED
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Examiner's Signature: George Goudrean Date Considered: 9-031								

Initial if reference was considered, whether or not citation with MPEP. Mark through citation if not considered. Include a copy of this citation form with your next correspondence to the Applicant(s).

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INFORMATION DISCLOSURE

CITATION FORM FOR PATENT APPLICATION

(FORM PTO - 1449)

Docket No.:

3536 C01

Serial No.:

09/775,173

Applicant(s):

JAMES CARDUCCI, ET AL.

Filing Date:

01-31-01

Group: 1636

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Docket No.: 3536 C01

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Applicant(s): JAMES CARDUCCI, ET AL.

Filing Date: 01-31-01

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Examiner's Signature:

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NUN B B 2007 Decket No.: 3536 C01

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Goudrean

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